INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 27, 2026

IGI Report Number	LG850631480
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	PEAR BRILLIANT
Measurements	9.90 X 5.94 X 3.52 MM

GRADING RESULTS

Carat Weight	1.20 CARAT
Color Grade	D
Clarity Grade	VVS 2

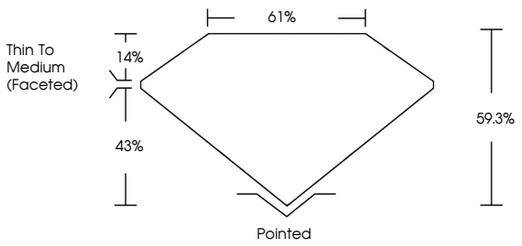
ADDITIONAL GRADING INFORMATION

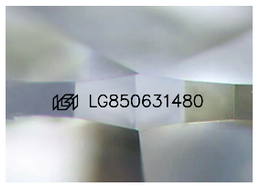
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG850631480

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG850631480
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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Measurements 9.90 X 5.94 X 3.52 MM

GRADING RESULTS
Carat Weight 1.20 CARAT
Color Grade D
Clarity Grade VVS 2

61%
Thin To Medium (Faceted)
14%
43%
59.3%
Pointed

ADDITIONAL GRADING INFORMATION
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG850631480
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

IGI

October 27, 2026
IGI Report No LG850631480
PEAR BRILLIANT
9.90 X 5.94 X 3.52 MM
Carat Weight 1.20 CARAT
Color Grade D
Clarity Grade VVS 2
Depth 59.3%
Table 61%
Girdle Thin To Medium (Faceted)
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG850631480
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa